

United States Patent and Trademark Office



APPLICATION NO.	FILING DATE	FIRST NAMED INVENTOR	ATTORNEY DOCKET NO.	CONFIRMATION NO
09/768,912	01/24/2001	Hiroji Kawai	09792909-4785	5026
7:	590 06/02/2003			
SONNENSCHEIN NATH & ROSENTHAL Sears Tower Wacker Drive Station P.O. Box 061080 Chicago, IL 60606-1080			EXAMINER	
			MENEFEE, JAMES A	
			ART UNIT	PAPER NUMBER
Cinicago, 12	0000 1000		2828	

DATE MAILED: 06/02/2003

Please find below and/or attached an Office communication concerning this application or proceeding.

			A
		Application No.	Applicant(s)
		09/768,912	KAWAI, HIROJI
Offi	c Action Summary	Examiner	Art Unit
		James A. Menefee	2828
The MA Period f r Reply	AILING DATE f this communication	appears on the c ver sheet	with the correspondence address
THE MAILING - Extensions of time after SIX (6) MOI - If the period for more in the period in the peri	ED STATUTORY PERIOD FOR RE DATE OF THIS COMMUNICATION THIS COMMUNICATION THIS FOR TH	N. R 1.136(a). In no event, however, may reply within the statutory minimum of the riod will apply and will expire SIX (6) Matute, cause the application to become	a reply be timely filed thirty (30) days will be considered timely. ONTHS from the mailing date of this communication. ABANDONED (35 U.S.C. § 133).
1)⊠ Respo	nsive to communication(s) filed on <u>(</u>	08 May 2003 .	
2a)☐ This ad	ction is FINAL . 2b)⊠	This action is non-final.	
closed	in accordance with the practice und		natters, prosecution as to the merits is C.D. 11, 453 O.G. 213.
Disposition of Cl			
) <u>9-12 and 24</u> is/are pending in the	• •	•
	ne above claim(s) is/are with	drawn from consideration.	
<u> </u>) is/are allowed.		ρ . 00
·) <u>9-12 and 24</u> is/are rejected.		Paul D
<u> </u>) is/are objected to.		PAUL IP
8) Claim(s Application Paper) are subject to restriction an ers	d/or election requirement.	SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800
9)⊡ The spec	cification is objected to by the Exam	iner.	32 SERVEN 2000
10)∐ The drav	ving(s) filed on is/are: a)∏ a	ccepted or b) objected to by	y the Examiner.
	ant may not request that any objection to	= ' '	
	osed drawing correction filed on		disapproved by the Examiner.
/ • • •	oved, corrected drawings are required in	• •	
	or declaration is objected to by the	Examiner.	
<u> </u>	U.S.C. §§ 119 and 120		
•	ledgment is made of a claim for ford	eign priority under 35 U.S.C	C. § 119(a)-(d) or (f).
·)☐ Some * c)☐ None of:		
1.⊠ C	ertified copies of the priority docum	ents have been received.	
2.□ C	ertified copies of the priority docum	ents have been received in	Application No
	opies of the certified copies of the papplication from the International attached detailed Office action for a	Bureau (PCT Rule 17.2(a))).
14) Acknowle	edgment is made of a claim for dome	estic priority under 35 U.S.0	C. § 119(e) (to a provisional application).
a) 🔲 The	translation of the foreign language	provisional application has	been received.
Attachment(s)			
2) Notice of Drafts 3) Information Disc	ences Cited (PTO-892) person's Patent Drawing Review (PTO-948) closure Statement(s) (PTO-1449) Paper No(5) 🔲 Notice (w Summary (PTO-413) Paper No(s) of Informal Patent Application (PTO-152)
S. Patent and Trademark Offic PTO-326 (Rev. 04-01)		e Action Summary	Part of Paper No. 18

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DETAILED ACTION

This action is in response to applicant's reply filed 8 May 2003.

Claim Rejections - 35 USC § 102

The following is a quotation of the appropriate paragraphs of 35 U.S.C. 102 that form the basis for the rejections under this section made in this Office action:

A person shall be entitled to a patent unless -

(e) the invention was described in (1) an application for patent, published under section 122(b), by another filed in the United States before the invention by the applicant for patent or (2) a patent granted on an application for patent by another filed in the United States before the invention by the applicant for patent, except that an international application filed under the treaty defined in section 351(a) shall have the effects for purposes of this subsection of an application filed in the United States only if the international application designated the United States and was published under Article 21(2) of such treaty in the English language.

Claims 9-11 and 24 rejected under 35 U.S.C. 102(e) as being anticipated by Sassa et al. (previously cited US 5,862,167).

Regarding claims 9 and 24, Sassa discloses a semiconductor device comprising a single crystal substrate 1 made of a material other than nitride III-V semiconductors, a device 3,4,5,6 formed on a major surface of said substrate 1 using III-V compound semiconductors, wherein an electrical connection is made directly by electrode 40 to said device through a via hole in said substrate 1 (see Fig. 4 and discussion thereof).

Regarding claim 10, the substrate 1 is a sapphire substrate.

Regarding claim 11, the device is a semiconductor laser using nitride III-V semiconductor materials.

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Claim Rejections - 35 USC § 103

The following is a quotation of 35 U.S.C. 103(a) which forms the basis for all obviousness rejections set forth in this Office action:

(a) A patent may not be obtained though the invention is not identically disclosed or described as set forth in section 102 of this title, if the differences between the subject matter sought to be patented and the prior art are such that the subject matter as a whole would have been obvious at the time the invention was made to a person having ordinary skill in the art to which said subject matter pertains. Patentability shall not be negatived by the manner in which the invention was made.

Claim 12 is rejected under 35 U.S.C. 103(a) as being unpatentable over Sassa. Sassa discloses the limitations of the claims as shown above, but does not disclose that the device is a FET. However, FETs are well known as being formed on substrates. The present invention concerns the device being formed on substrate where an electrical connection is made to the device through a via hole in the substrate. The type of device used is not critical. Since it is well known to form a FET on a substrate, and a FET should have some sort of electrical connection made thereto, then it would have been obvious to one skilled in the art to make use a FET as the device in place of the laser of Sassa by way of obvious engineering design choice.

Response to Arguments

Applicant's arguments with respect to the claims have been considered but are moot in view of the new ground(s) of rejection.

Conclusion

Any inquiry concerning this communication or earlier communications from the examiner should be directed to James A. Menefee whose telephone number is (703) 605-4367. The examiner can normally be reached on M-F 8:30-5.

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If attempts to reach the examiner by telephone are unsuccessful, the examiner's supervisor, Paul Ip can be reached on (703) 308-3098. The fax phone numbers for the organization where this application or proceeding is assigned are (703) 872-9318 for regular communications and (703) 872-9319 for After Final communications.

Any inquiry of a general nature or relating to the status of this application or proceeding should be directed to the receptionist whose telephone number is (703) 308-0956.

JM May 27, 2003

PAUL IP SUPERVISORY PATENT EXAMINER TECHNOLOGY CENTER 2800

Paul of